May 31, 2025

Nomination for the Kobayashi-Uchiike-Mikoshiba Prize

Mutsumi Kimura President International Display Workshops General Incorporated Association

Purpose of the Award

The International Display Workshops (IDW) owes its development and contribution to society to the lively activities of its participants, centering on presenters, and those involved in its operation. These contributions specifically include presenters' pioneering academic and technical achievements, the nurturing of next-generation experts through education and technical guidance, and dedicated efforts as various committee members supporting the smooth operation of IDW. The Kobayashi-Uchiike-Mikoshiba Prize (KUM Prize) is awarded to express our respect and gratitude for the recipient's remarkable past contributions. It also conveys our hope that the recipient will continue to serve as a central figure, driving the further development of IDW and its contributions to society.

Number of Awards

A total of three awards will be presented, with one award for each of the three categories below. (Approximately 0.2% on the basis of 1,300 participants.)

- i Materials-related
- ii Devices-related
- iii Systems-related

Nomination Regulations

(1) Prerequisites for Candidates

Candidates must satisfy all of the following prerequisites.

- · The nominee must have presented five or more papers at IDW, including co-authored papers
- · The nominee must have performed a pioneering academic or scientific
- The nominee must have made a significant contribution to the operation of IDW

However, the following are not eligible to be candidates.

- · IDW General Incorporated Association directors or auditors
- Members of the KUM Awards Committee
- (2) Prerequisites for Nominators

Personnel of the IDW General Incorporated Association, or either a Workshop Chair, Workshop Program Chair or Workshop General Secretary.

NB: Nominations must have the recommendation of at least three other persons, and self-nominations will not be accepted.

(3) Nomination method

Send the nomination form (including the three or more recommendations) to the following e-mail address by July 18.

Chair of the KUM Awards Committee Tomokazu Shiga: tomokazu.shiga@idw.or.jp

Nomination Form (Application Guidance)

Title: "2025 Kobayashi-Uchiike-Mikoshiba Prize Nomination"

- Nominee Information: Provide the nominee's full name, current place of employment and position, address, telephone number and email address.
- Nomination Category: Select one from Materials, Devices, or Systems
- Proposed Citation: Detail the reason for this nomination in 30 words or less.
- Education and Professional History: Provide the nominee's itemized curriculum vitae in chronological order. Emphasize positions of authority regarding work, missions and in particular any items subject to awards.
- 5. List of Papers Presented at IDW (minimum five):
 - (1)
 - (2)
 - (3)
 - (4)
 - (5)
- 6. IDW Committee Service History:
- 7. Description of Most Significant Achievement(s) or Outstanding Technical Leadership: State achievements relevant to the prize. In order to make an adequate appeal state these quantitatively, and in an easily understood and well-arranged manner. With regard to important points, add any related items to which the following apply. The degree of technical contribution made by candidates themselves is vital. Managerial contributions are hardly evaluated.
- 8. Supportive Material:

List related papers and books (mark the important literature with annotations, including any coauthors). Also provide the number of related patents. For important items, add an outline and annotations on efficacy etc. Do not count overseas and domestic patents separately.

- 9. Professional Awards, Other Professional Society Affiliations, and Membership Grades: List professional awards, contributions made to other professional societies, and any other relevant information.
- 10. Nominator Information:

Provide the names, affiliations, and email addresses of at least three persons.

- (1)
- (2)

(3)

Complete nominations in English or Japanese, and please keep them within four to eight pages in length in A4 format or equivalent.